



Department of Metallurgical and Materials Engineering
NATIONAL INSTITUTE OF TECHNOLOGY
TIRUCHIRAPPALLI

February 17, 2012

Applications are invited Junior Research Fellow (JRF) and Technical Assistant (TA) in the project titled “*Development of light weight in situ metal intermetallic laminates for defence applications*” sponsored by Defence Research and Development (DRDO) under ER & IPR scheme, New Delhi.

1. Name of the Position : **Junior Research Fellow (JRF)**
Minimum Qualification : B.E. or B.Tech. in Metallurgical Engineering (or) allied Engineering with 1st class. 1-2 years of experience in diffusion bonding will be preferred.
Emoluments : 16,000/- p.m. (and 20% HRA)
Age Limit : preferably less than 26 years
Duration : 1 Year (extendable up to 3 years)
2. Name of the Position : **Technical Assistant (TA)**
Minimum Qualification : ITI with around 10 years experience (mechanic, turner, fitter, and in relevant area)
Emoluments : 8,000/- p.m. (fixed)
Duration : 1 Year (extendable up to 3 years)

The positions are purely temporary and till the project ends. Eligible candidates for JRF may send filled in application in prescribed format to the following address on or before **06-03-2012** by post, whereas TA applications can send their bio-data only with a cover letter to the following address:

Dr. K. Siva Prasad,
Assistant Professor,
Department of Metallurgical and Materials Engineering,
National Institute of Technology,
Tiruchirappalli – 620 015.

The short listed candidates will be intimated by **email** (only). Selection will be based on interview. Please note that no TA and DA will be paid to the candidates, who were called for interview.

Dr. K. Siva Prasad
Principal Investigator

APPLICATION FOR JRF

1.	Name of the Applicant (In BLOCK Letters)	:	
2.	Father's Name	:	
3.	Date of Birth	:	
4.	Nationality	:	
5.	Gender: Male/Female	:	
6.	Address for Correspondence with email and Phone Numbers	:	
7.	Educational Qualification (From Degree onwards)	:	

Degree Passed	Name of Board/University	Year of Passing	Division/ % Marks	Branch/ Specialization

9.	GATE/NET score, if any	:	
10.	Refereed Journal Papers published, if any	:	
11.	Any other Relevant Information, if any	:	

Declaration

I hereby declare that the statements made in this application are true and complete to the best of my knowledge and belief and nothing has been concealed/ distorted. If any time I am found to have concealed/ distorted any materials/ information, my engagement on purely contract basis is liable to be terminated without notice.

Date:

Signature